



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.10/075,193
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Inventor.....Shenlin Chen et al.
Assignee.....Micron Technology, Inc.
Group Art Unit.....2813
ExaminerHuynh, Y.
Attorney's Docket No.MI22-1927
Title: Methods of Forming a Capacitor Structure

RESPONSE TO DECEMBER 14, 2004 NOTICE OF ALLOWANCE
TO ACCOMPANY RCE FILING

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AMENDMENTS

Introductory Comments

This response accompanies a petition to withdraw from issue and request for continued examination of the application. Applicant remarks as follows.